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| SERIAL NUMBER<br>09/994,284 | FILING DATE<br>11/26/2001<br><br>RULE | CLASS<br>438 | GROUP ART UNIT<br>2823 | ATTORNEY DOCKET NO.<br>CU-2636 VE |
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\*\* CONTINUING DATA \*\*\*\*\*

*none*  
*wp*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2000-70219 11/24/2000

|   |  |                        |                      |                            |
|---|--|------------------------|----------------------|----------------------------|
| Foreign Priority claimed<br><input checked="" type="checkbox"/> yes <input type="checkbox"/> no   | STATE OR<br>COUNTRY<br>KOREA,<br>REPUBLIC OF | SHEETS<br>DRAWING<br>6 | TOTAL<br>CLAIMS<br>9 | INDEPENDENT<br>CLAIMS<br>1 |
| 35 USC 119 (a-d) conditions met<br><input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance |  |                        |                      |                            |
| Verified and Acknowledged<br><i>[Signature]</i><br>Examiner's Signature Initials  |  |                        |                      |                            |

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## TITLE

Method of forming a metal gate in a semiconductor device

|                                   |   |   |
|-----------------------------------|---|---|
| FILING FEE<br><br>RECEIVED<br>740 | FEES: Authority has been given in Paper<br>No. _____ to charge/credit DEPOSIT ACCOUNT<br>No. _____ for following: | <input type="checkbox"/> All Fees<br><input type="checkbox"/> 1.16 Fees ( Filing )<br><input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )<br><input type="checkbox"/> 1.18 Fees ( Issue )<br><input type="checkbox"/> Other _____<br><input type="checkbox"/> Credit |
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